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NGC-212/12-1167

**IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE**

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OCT 17 2005

**Inventor(s):** Raffi Nazare Elmadjian

**Case No.:** NGC-212/12-1167

**Examiner**

Ken Chan Chin

**Serial No.:** 10/688,238

**Art Unit:**

1765

**Filing Date:** 10/18/2003

**Title:** WAFER ETCHING TECHNIQUES

**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop Amendment, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA 22313-1450, at fax number (571) 273-8300, on October 17, 2005.



Carmen B. Patti  
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Date of Signature: October 17, 2005

Commissioner for Patents  
Mail Stop Amendment  
Group Art Unit 1765  
Attention: Examiner Ken Chan Chin  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Fax Number (571) 273-8300

**AMENDMENT**

Dear Sir:

This paper is filed in response to the Office Action mailed July 19, 2005 in connection with the above-identified application. A response to the Office Action is due October 19, 2005. Therefore, this Response is timely filed.

1

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